



Paul E. Rauch, Ph.D.
Name of Applicant, Assignee or
Registered Representative

Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Thinghao F. Wang

Serial No. 10/071,809

Filing Date: February 7, 2002

For METHOD FOR SELECTIVELY
ETCHING SILICON AND/OR
METAL SILICIDES

Examiner: Deo, Duy Vu

Group Art Unit No.: 1765

TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is:

- | | |
|-------------------------------------|--|
| <input checked="" type="checkbox"/> | Credit Card Payment Form |
| <input checked="" type="checkbox"/> | One Month Extension of Time (in duplicate) |
| <input checked="" type="checkbox"/> | Declaration Under 37 C.F.R. § 1.132 including Exhibit A (Mr. Ramkumar's resume) |
| <input checked="" type="checkbox"/> | Request for Reconsideration |
| <input checked="" type="checkbox"/> | No additional fee is required. |
| <input checked="" type="checkbox"/> | The Commissioner is hereby authorized to charge any fees associated with this communication not covered by check or credit card payment or credit any overpayment to Deposit Account No. (43-320). A duplicate copy of this sheet is attached. |

Respectfully submitted,

Paul E. Rauch, Ph.D.
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